

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kenichi Ishibashi et al.
Serial No.: 10/543,050
Confirmation No.: 2592
Filed: December 12, 2005
For: PHOTOELECTRIC CONVERSION ELEMENT AND PROCESS
FOR FABRICATING THE SAME, ELECTRONIC APPARATUS
AND PROCESS FOR FABRICATING THE SAME, AND
SEMICONDUCTOR LAYER AND PROCESS FOR FORMING THE
SAME
Examiner: C. L. Novacek
Art Unit: 2822

Certificate of Electronic Filing Under 37 CFR 1.8	
I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted via the Office electronic filing system in accordance with § 1.6(a)(4).	
Dated: <u>6/16/10</u>	Signature: <u>Jen Lovelle (Jen Lovelle)</u>

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Final Office Action dated March 16, 2010, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.